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PATENT  
81788.0263

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Akira Tanaka, et al.

Serial No: 10/724,570

Confirmation No.: 8635

Filed: November 26, 2003

For: SEMICONDUCTOR LASER ELEMENT,  
METHOD FOR FABRICATION THEREOF,  
AND MULTI-WAVELENGTH  
MONOLITHIC SEMICONDUCTOR LASER  
DEVICE

Art Unit: 2828

Examiner: Tod Thomas Van Roy

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:  
Mail Stop Amendment, Commissioner for Patents,  
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November 3, 2005

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William H. Wright

Name

Signature

Date

**ELECTION**

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Restriction Requirement dated October 14, 2005. Applicant elects for continued prosecution the species of FIGS. 1-3. Applicant submits that claims 1-18 are readable on the elected species. This election is made without traverse.

Action on the merits is respectfully requested.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: November 3, 2005

By:

William H. Wright

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